PATENT ATTY. DOCKET NO.: P67358US0



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner: M. Lewis

2822

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Hyung-Jun KIM Group Art Unit: 2822

Filed: December 17, 2001

Serial No.: 10/015,757

For: SEMICONDUCTOR DEVICE CAPABLE OF PREVENTING CORROSION OF

METAL WIRES FROM CMP (CHEMICAL MECHANICAL POLISHING) PROCESS

TRANSMITTAL

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

Transmitted herewith is an Amendment Under Rule 1.111 for filing in the above-captioned patent application.

The fee has been calculated as shown below:

	Claims Remaining After Amendment		Highest Number	Present Extra	Small Entity		Other Than A Small Entity	
			Previously		Rate Addit.	(or)	Rate Addit.	
			Paid For		Fee		Fee	
Total	12	-	20 =	0	x 09 = \$		x 18 = \$	
Indep.	03	-	03=	0	x 42 = \$		x 84 = \$	
First Presentation of Multiple Dependent Claims					+130 = \$		<u>+ 260 = \$</u>	
Total Additional Fee					\$		\$	

A check in the amount of \$____ is attached for:

XXXX If a Petition for Extension of Time is necessary and the Petition and/or the check is not enclosed, this will act as the Petition and applicant herewith petitions the Commissioner to extend the time for response and charge any fees necessary under 37 CFR 1.17 (a)(1)-(5) to Deposit Account No. 06-1358. The Commissioner is also authorized to charge payment of any other additional fees associated with this communication or credit any overpayment to Deposit Account No. 06-1358. A duplicate copy of this sheet is attached.

Respectfully submitted, JACOBSON HOLMAN PLLC

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Date: August 3, 2004

YSH:SCB

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In re the Application of:

Hyung-Jun KIM Group Art Unit: 2822

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AMENDMENT UNDER RULE 1.111

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action (Paper No. 04292004) dated May 5, 2004, kindly amend the above-identified patent application as set forth herein.